

In re the Application of: Kazuo TESHIROGI et al. Group Art Unit: 1733

Application Number: 10/718,653 Examiner: John L. GOFF

Filed: November 24, 2003 Confirmation Number: 1182

For: FILM LAMINATION APPARATUS AND METHOD AND A MANUFACTURING

METHOD OF A SEMICONDUCTOR APPARATUS

Attorney Docket Number: 032131

Customer Number: 38834

## RESPONSE UNDER 37 C.F.R. §1.111

Mail Stop Amendment Commissioner for Patents P. O. Box 1450 Alexandria, VA 22313-1450 March 6, 2007

Sir:

This paper is filed in response to the Office Action dated December 6, 2006.

Remarks/Arguments begin on page 2 of this paper.